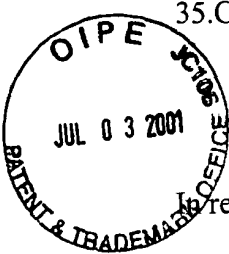


2812



35.C15122

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PATENT APPLICATION  
JUL 10 2001  
TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

SHIGENORI ISHIHARA

Application No.: 09/779,645

Filed: February 9, 2001

For: ORGANIC SUBSTANCE  
REMOVING METHODS,  
METHODS OF PRODUCING  
SEMICONDUCTOR DEVICE,  
AND ORGANIC SUBSTANCE  
REMOVING APPARATUSES

Examiner: Not Yet Assigned

Group Art Unit: 2812

July 2, 2001

RECEIVED  
JUL 25 2001  
TC 1700

Commissioner for Patents  
Washington, D.C. 20231

SECOND INFORMATION DISCLOSURE STATEMENT

Sir:

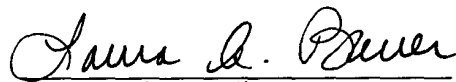
In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office, by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
Attorney for Applicant  
Registration No. 29,767

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